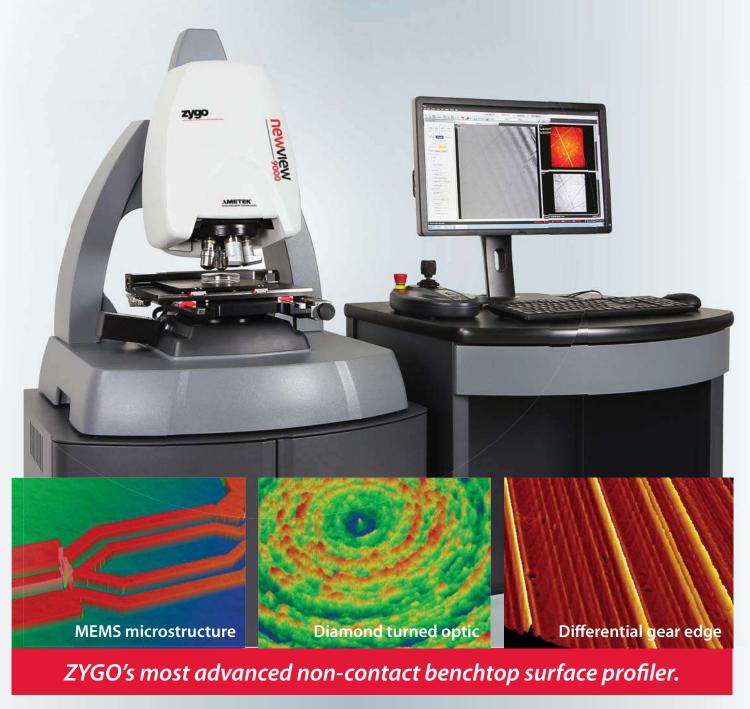
**Zygo**°

# newview 9000





# NewView<sup>™</sup> 9000 profiler product highlights

An advanced non-contact 3D metrology tool for surface applications demanding precise quantitative, topographic, volumetric, and texture characterization.



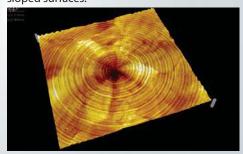
**Full 3D visualization** of virtually any surface: Topography and texture on rough, polished and highly sloped surfaces—even transparent films

Robust measurements—new technology reveals topography data nearly everywhere there is a feature, even on rough and angled surfaces

**Fast**—sub-nanometer vertical resolution at high speeds, independent of magnification

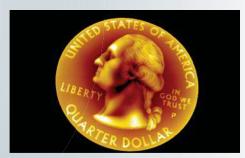
# The latest edition in the field-proven leader in 3D surface profiling

Proprietary ZYGO technology enables the NewView 9000 to push beyond the traditional limits of interferometric profilers—to provide meaningful height data virtually everywhere there is a sample, even on extremely rough, low reflectivity, and highly sloped surfaces.

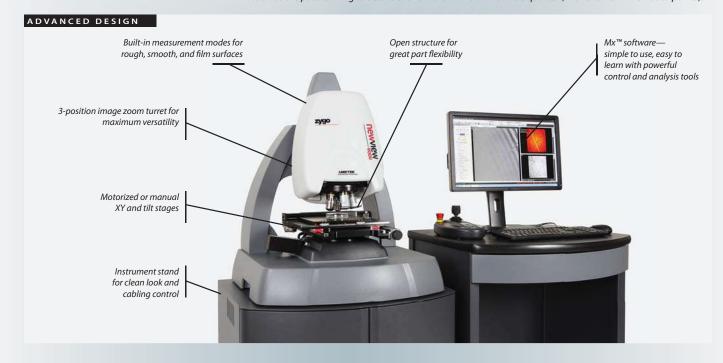


The NewView 9000 can analyze process fingerprints such as the post-turning structure of this nickel mirror.

When combined with advanced techniques like SureScan™ technology, for robust performance even in the presence of vibration, this improved visualization and metrology capability provides an exceptionally powerful platform for surface characterization.



Measure larger objects and highly sloped surfaces, like this US quarter (with over 25 million data points).

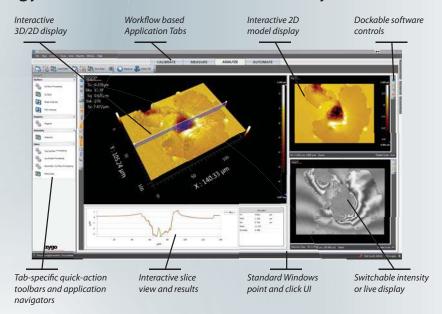


# Intuitive software

# The next standard in metrology software: Mx<sup>™</sup> control and analysis

National Street Street

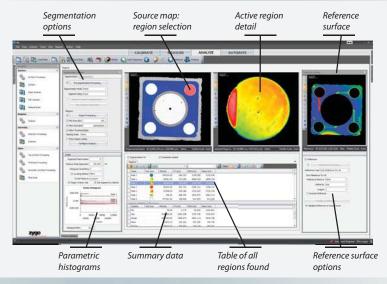
Interactive and detailed plots show full 2D or 3D data; profile slices, material ratio, slope analysis, and PSD views. With built-in SPC, pass/fail indication, data reporting and run charts, production quality analysis is simple.



#### ADVANCED ANALYSIS

# Regions analysis

Regions analysis demonstrates the power of area measurements. In an individual data set, whether from a single field of view or stitched as a composite, regions that are separated laterally and/or vertically can be compared.



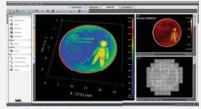
#### AUTOMATION

# Stitching and patterned sampling

Stitching is a way of enlarging a field of view and increasing data density. With a motorized XY stage, adjacent fields-of-view are matched at their edges, and joined together into a larger image.

Pattern sampling uses Mx software capabilities of stage programming and data acquisition with automated stages. Stitching and pattern sampling require motorized staging options.

**Stitching** with the NewView<sup>™</sup> 9000 profiler allows you to explore surfaces at high magnification with high data density.



**Pattern sampling** is measuring different locations on the stage, such as a tray of samples or evaluating different areas on a larger object.



The Stitching Preview eliminates stitching grid guesswork



Automated sampling at each location results in multiple measurements from one loading of the stage



#### **Features**

- CSI technology provides maximum application flexibility— for surface heights from angstroms to millimeters
- SureScan™ technology enables precision metrology in vibration-prone environments
- Smart PSI technology enables sub-Å surface metrology in seconds
- Correlation to 2D and 3D standards with ISO 25178 compliance
- Streamlined Mx<sup>™</sup> software
- Built in pass/fail, SPC, reporting, & statistics
- Open structure provides clear part visibility and access with large work volume (H x W x D)
- 89 x 150 x 150 mm (standard system)
- 265 x 150 x 150 mm (system w/ optional 176 mm riser kit)
- Built in 75 mm head riser
- Optional thick films analysis for transparent films > 400 nm thick
- Optional 2D analysis Vision Software Suite

#### Performance

#### **Surface Topography Repeatability**

• 0.08 nm for all magnifications

#### Repeatability of the RMS

■ 0.008 nm

#### **Sample Stage**

- Manual XY: 100 mm travel
- Motorized XY: 150 mm XY travel
- Tilt: +/- 4° tilt

### System Options

- Manual, motorized, and encoded stage options
- Available built-in vibration isolation
- Instrument stand with seismic restraint locations
- Discrete optical image zoom lenses

# Physical Characteristics

#### Dimensions $(H \times W \times D)$

- $75 \times 64 \times 56$  cm (benchtop mainframe)
- $151 \times 73 \times 61$  cm (with stand)

#### **System Weight**

- 91 kg benchtop configuration
- 229 kg with stand configuration

## Flexible Configurations



#### **Gantry Risers**

Optional 35 mm (1.3 in.) and 176 mm (6.9 in.) base riser kits work with the included 75 mm head riser to increase standard work volume by more than 9 inches, to enable access to very large parts and deeply recessed surfaces.

#### Software

Additionally, optional software licenses for vision analysis and transparent films analysis enable multifunctional tool use for a wider variety of applications such as materials characterization, precision machining,

prosthetics, MEMS, semiconductor, consumer electro-optics, and optical surface manufacturing.

#### **Objectives**

ZYGO maintains the largest selection of interferometric objectives among available optical surface profilers, with standard working distances up to 40 mm and custom configurations in excess of 50 mm.

Available objectives include:

- Standard working distance objectives from 1× to 100× magnification. Our 100× objective with 0.85 NA has the finest optical resolution of any interferometric profiler.
- Long working distance (LWD), and super long working distance (SLWD) objectives from 1x to 10x magnification.
- Specialized glass compensated (GC)
   objectives enable sample observation
   through a transmissive window.

## Largest selection of objectives available in optical metrology

Objective Working Distance (mm)

Magnification	1×	2×	2.75×	5×	5.5×	10×	20×	50×	100×
Michelson/Mirau Standard working distance	-	-	4.5	-	8.0	7.4	4.7	3.4	0.5
Long Working Distance	8.0	21.0	-	21.0	-	19.0	-	-	-
Super-Long Working Distance	40.0	-	-	40.0	-	-	-	-	-
Glass Compensated	-	18.5	-	19.0	-	18.0	-	-	-

# Accessorize your NewView 9000 Profiler

Accessory	Description				
Workstation	<ul> <li>Side desk designed to complement the system and accommodate the monitor, keyboard, mouse and joystick pendant with convenience drawer and cable management</li> </ul>				
Objective turret	<ul><li>4 position, motorized and encoded</li><li>Various objective mounting and parfocal adapters available</li></ul>				
Calibration standards	<ul> <li>Step-height: 0.088 µm, 1.8 µm, and 25 µm</li> <li>SiC Reference Flat: choice of 30 mm and 50 mm diameter</li> <li>Lateral: Standard and high-precision versions</li> </ul>				
Gantry risers	<ul> <li>35 mm and 176 mm riser kits</li> </ul>				
Sample holders	<ul> <li>150 mm square vacuum holder</li> </ul>				





#### **ZYGO CORPORATION**

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